

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Appl. No. : 10/537,952 Confirmation No. 1520  
Applicant : Joseph M. AMATO  
Filed : June 8, 2005  
TC/A.U. : 2829  
Examiner : Tung X. Nguyen

Docket No. : **US02 0574 US**  
Customer No. : 65913

Title: RESISTOR STRUCTURES TO ELECTRICALLY  
MEASURE UNIDIRECTIONAL MISALIGNMENT OF  
STITCHED MASKS

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE & AMENDMENT AFTER NOTICE OF ALLOWANCE**

Sir:

In response to the Notice of Allowance dated May 16, 2008, please consider the following. Examiner had noted defects in the Oath & Declaration. Applicant has included a replacement Oath & Declaration along with the Issue Fee Payment.

**Amendments to the Specification** there are no amendments this paper.

**Amendments to the Claims** there are no amendments in this paper.

**Remarks/Arguments** begin on page 2 of this paper. A replacement Oath & Declaration follows.